Application Number:	10601401					
Application Number:	10681481					
Filing Date:	08-Oct-2003					
Title of Invention:	METHOD OF CLEANING SEMICONDUCTOR SURFACES					
First Named Inventor/Applicant Name:	Paul A. Farrar					
Filer:	Karen L Himmel/LeShere Wolfe					
Attorney Docket Number:	1303.112US1					
Filed as Large Entity						
Utility under 35 USC 111(a) Filing Fees						
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)	
Basic Filing:					I	
Pages:						
Claims:						
Miscellaneous-Filing:						
Publ. Fee- early, voluntary, or normal		1504	1	300	300	
Petition:						
Patent-Appeals-and-Interference:						
Post-Allowance-and-Post-Issuance:						
					1	

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
	Tot	(\$)	1810	